



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

#16 /IDS
NB
7/24/02

the application of:

Wilk *et al.* Docket: TI-24742
Serial No.: 09/176,422 Examiner: N. Berezny
Filed: 10/21/98 Art Unit: 2823
For: Low Temperature Method for Forming a Thin, Uniform Oxide

INFORMATION DISCLOSURE STATEMENT

May 10, 2002

Assistant Commissioner For Patents
Washington, D. C. 20231

MAILING CERTIFICATE UNDER 37 CFR § 1.8
I hereby certify that this correspondence is being deposited with the
United States Postal Service as first class mail in an envelope addressed
to: Assistant Commissioner for Patents, Washington, DC 20231 on

May 10, 2002
Tina Smith
Tina Smith

Examiner:

Applicants wish to bring to the attention of the Patent and Trademark Office the information noted on the enclosed PTO-1449.

All of these reference(s) were first cited in a communication from a foreign patent office in a counterpart foreign application not more than three months prior to filing this statement.

Copies of the European Search Report and reference(s) CA - CI are enclosed. Applicants believe that no fee is due. However, the Commissioner is authorized to charge any necessary fee to Deposit Account 20-0668 of Texas Instruments Incorporated.

Respectfully submitted,


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